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APPLICANTS  Kiyoshi Arita, Fukuoka, JAPAN;  ** CONTINUING DATA ***** <i>None</i> <i>TN</i>  ** FOREIGN APPLICATIONS ***** JAPAN 2002-336415 11/20/2002 JAPAN 2002-336416 11/20/2002 <i>TN</i>  IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 02/19/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>Allowance</i> Acknowledged <i>Examiner's Signature</i> <i>TN</i> <i>Initials</i>		STATE OR COUNTRY JAPAN	SHEETS DRAWING 11	TOTAL CLAIMS 27	INDEPENDENT CLAIMS 3
ADDRESS 00116 PEARNE & GORDON LLP 1801 EAST 9TH STREET SUITE 1200 CLEVELAND , OH 44114-3108					
TITLE Method of manufacturing semiconductor device, plasma processing apparatus and plasma processing method					
FILING FEE  RECEIVED 1276	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue )		